

*A3*  
*Cont*

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contact protuberance 50 is in contact with the corresponding one of the aperture defining contact walls 13.

### IN THE CLAIMS

Please rewrite claims 1, 3, 10, 12, 15, and 18 as follows:

1. (Once Amended) An EMI shielding structure, comprising:

*A4f*  
a printed circuit having at least one contact protuberance; and

an EMI shield member formed with an aperture receiving the contact protuberance,

the EMI shield member having a contact wall defining the aperture, the aperture defining contact wall being in contact with the contact protuberance received in the aperture, the contact protuberance being dimensioned such that the contact protuberance supports the EMI shield member.

3. (Once Amended) An EMI shielding structure, comprising:

*A5*  
a printed circuit having at least one contact protuberance; and

an EMI shield member formed with an aperture receiving the contact protuberance,

the EMI shield member having a contact wall defining the aperture, the aperture defining contact wall being in contact with the contact protuberance received in the aperture,

*AB  
last*

the contact protuberance having a vertex protruded through the aperture beyond the EMI shield member, the contact protuberance being dimensioned such that the contact protuberance supports the EMI shield member.

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10. (Once Amended) An EMI shielding structure, comprising:

a printed circuit having at least one contact protuberance; and

an EMI shield member formed with an aperture receiving the contact protuberance,

*AM*

the EMI shield member having a contact wall defining the aperture, the aperture defining contact wall being in contact with the contact protuberance received in the aperture,

the contact protuberance having a uniform cross sectional area, being fitted into the aperture, and being dimensioned such that the contact protuberance supports the EMI shield member.

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12. (Once Amended) An EMI shielding structure, comprising:

a printed circuit having at least one contact protuberance; and

an EMI shield member formed with an aperture receiving the contact protuberance,

*AM*

the EMI shield member having a contact wall defining the aperture, the aperture defining contact wall being in contact with the contact protuberance received in the aperture,

the contact protuberance having a first portion and an integral second portion fitted into

the aperture,

*Cont*  
the second portion having a cross sectional area less than a cross sectional area of the first

portion,

the first portion allowing the EMI shield member to rest and be supported thereon.

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15. (Once Amended) A method of assembling an EMI shielding structure, comprising:

forming a printed circuit with at least one contact protuberance;

*AS*  
forming an EMI shield member with an aperture and a contact wall defining the aperture;

and

placing the EMI shield member in a desired alignment over the printed circuit in a manner that the aperture receives the contact protuberance in contact with the aperture defining contact wall and such that the contact protuberance supports the EMI shield member.

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18. (Once Amended) An EMI shielding structure, comprising:

*AG*  
a ground plane;

at least one contact protuberance on the ground plane; and

an EMI shield member formed with an aperture receiving the contact protuberance,